FIG.1

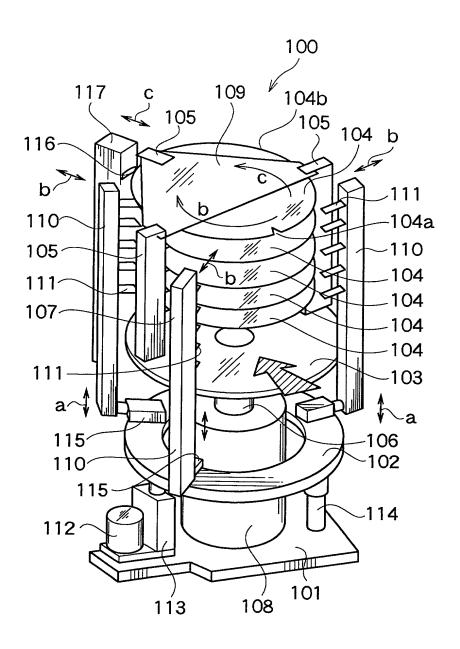


FIG.2

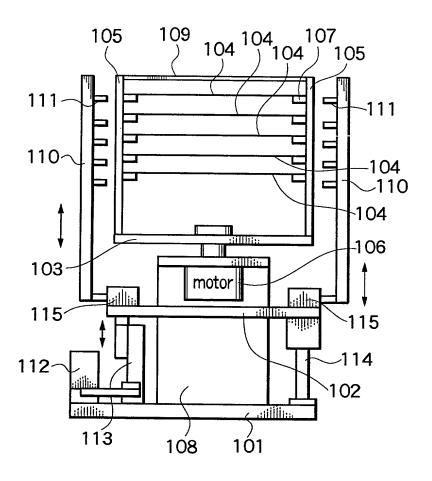


FIG.3A

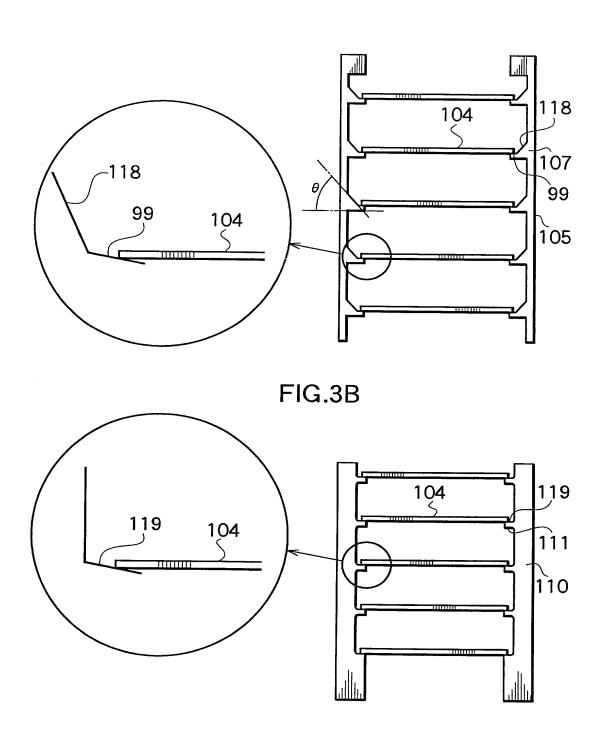


FIG.4

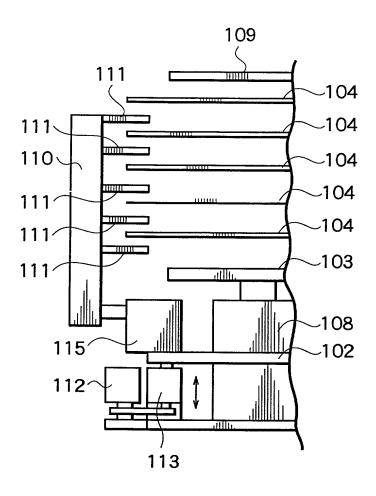


FIG.5A

116

116

116

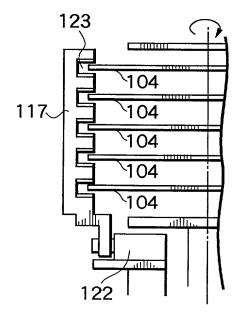
104

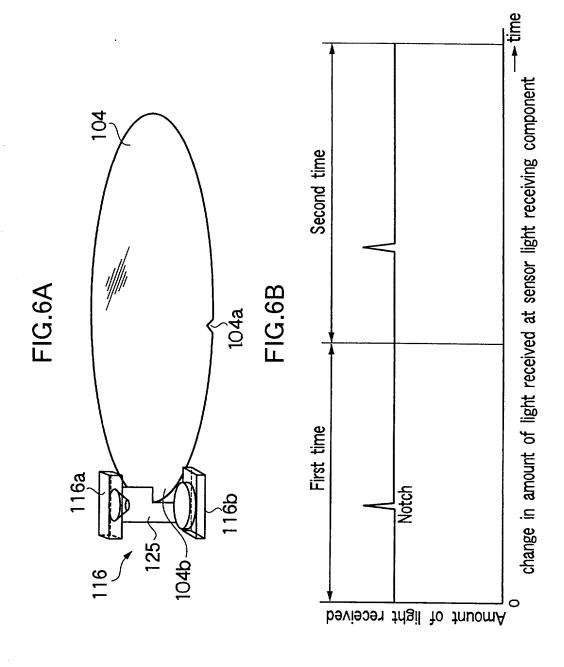
104

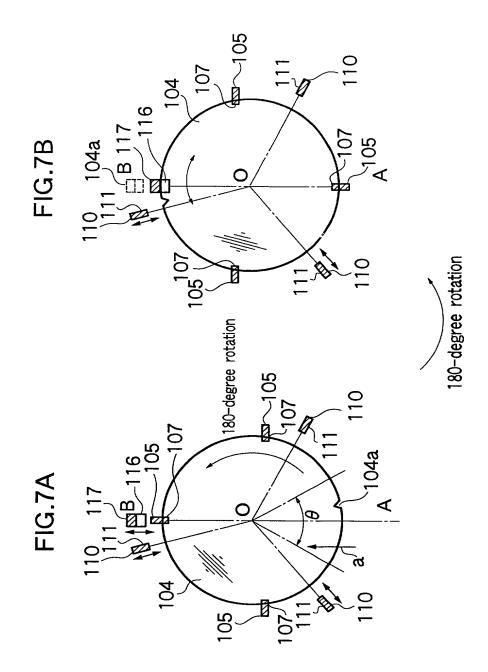
104

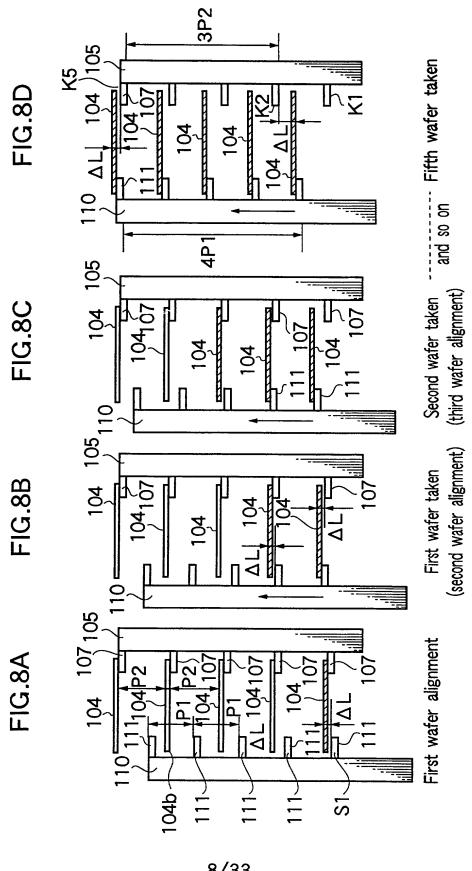
104

FIG.5B



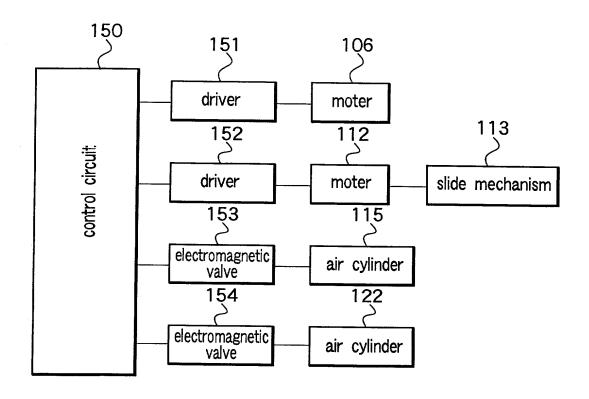


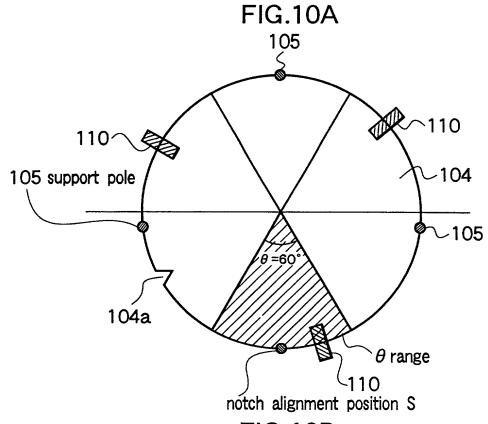




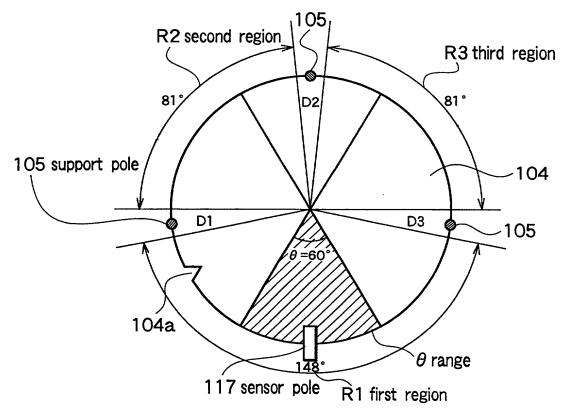
8/33

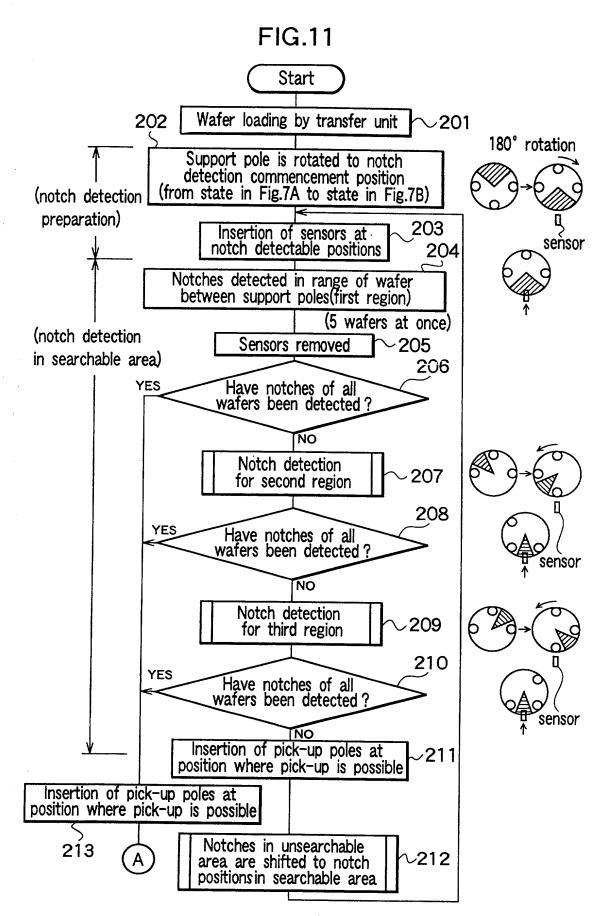
FIG.9



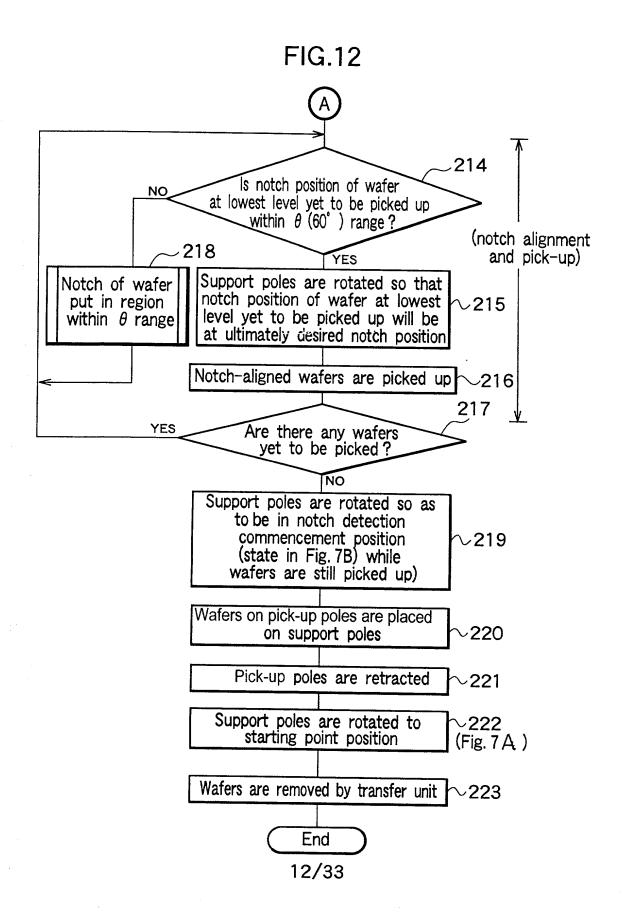








11/33



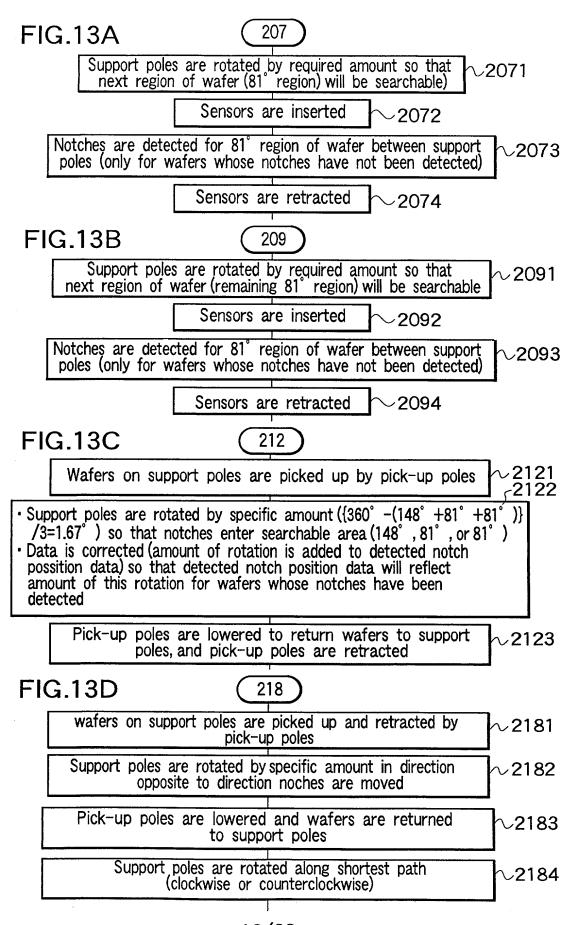


FIG.14A FIG.14D Support pole rotation Start B| 117 明晦 110-104 110~ 104a 105 -105 105 _110 110/6 110~ **-105** FIG.14B FIG.14E Just support poles rotated wafer retraction Wafer rotation #B~117 用恒 110 110~ 104 104a 105 105 105 110 110

117

104

^{_}105

117

105

-105

104a

110

104

₂105

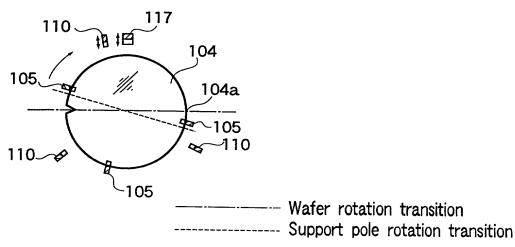
∞110

104a

#1

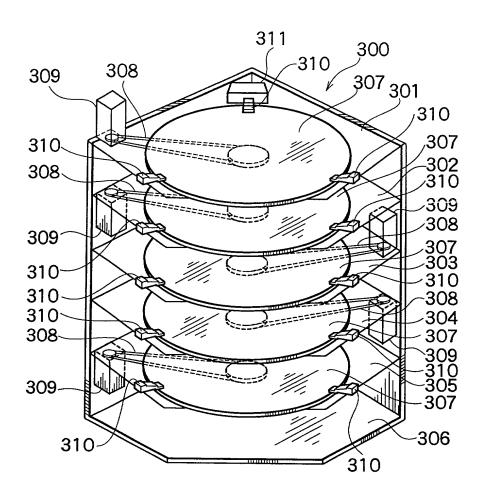
FIG.14C Wafer rotation

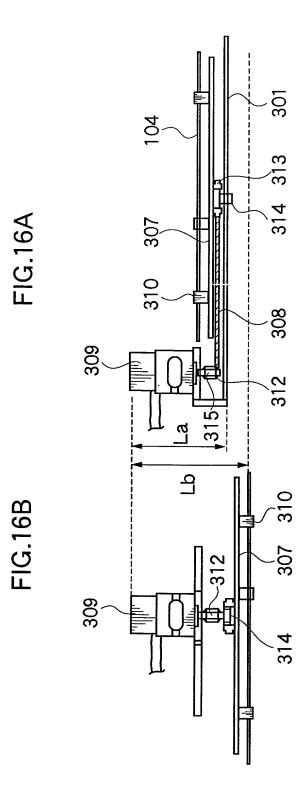
-105



110~6

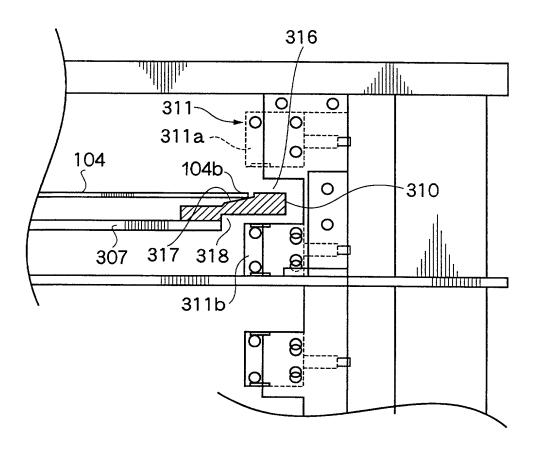
FIG.15





16/33

FIG.17



Relationship between support pins and notch detection sensors

FIG.18

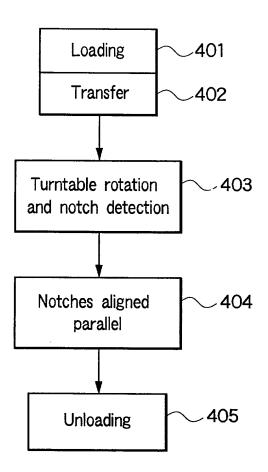


FIG.19A

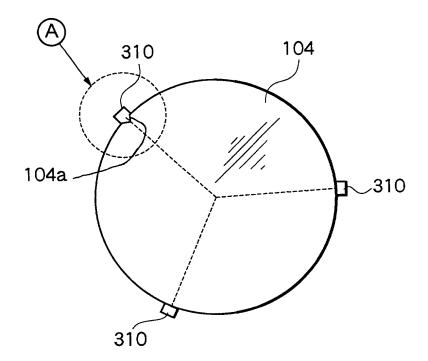


FIG.19B

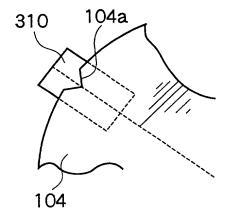


FIG.20A

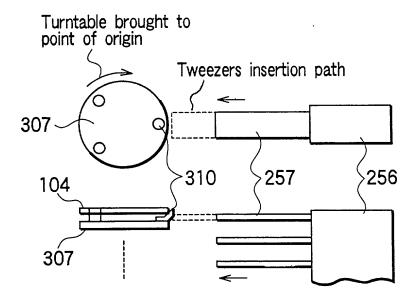
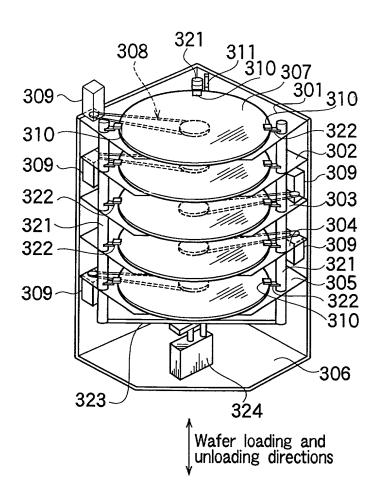


FIG.20B

310
257
256
310
307
104
310
257
256
310
307

FIG.21



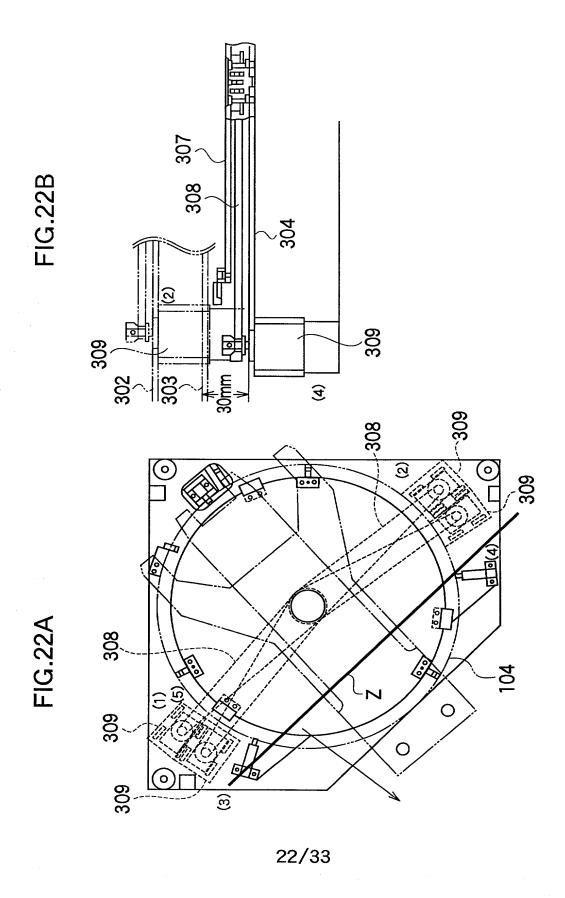


FIG.23A

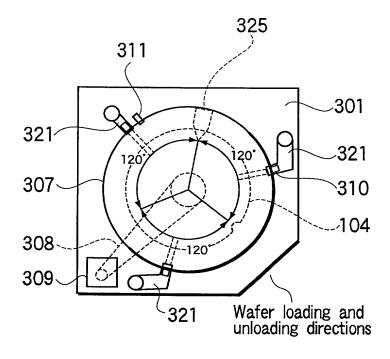


FIG.23B

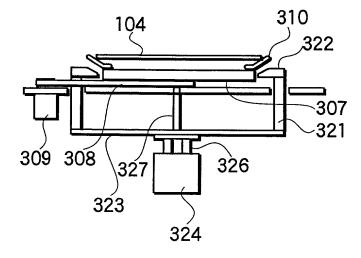


FIG.24

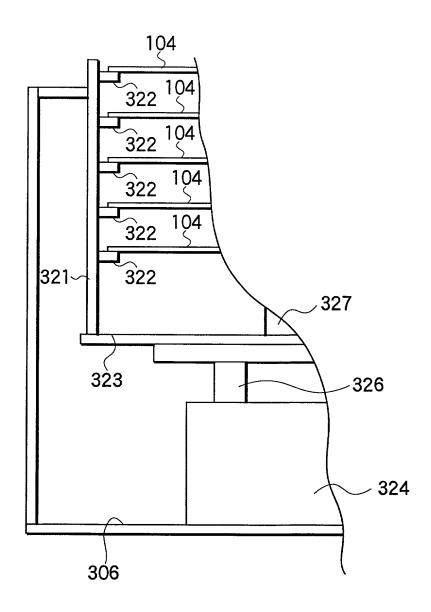


FIG.25A

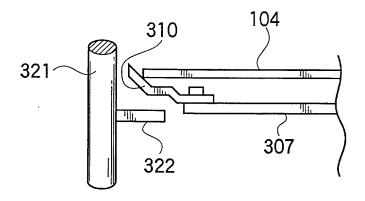


FIG.25B

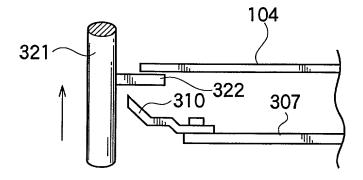


FIG.26

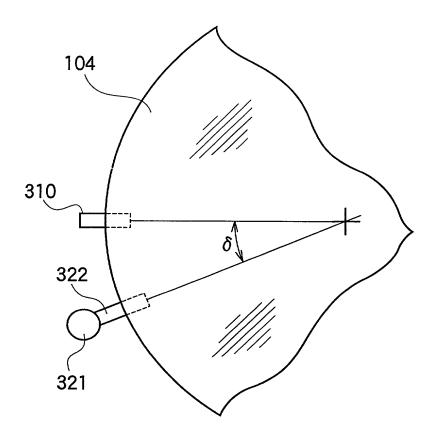
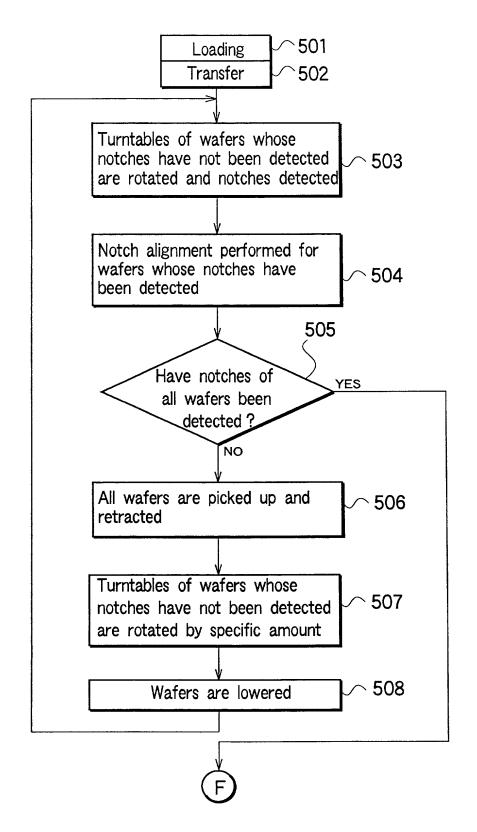


FIG.27



27/33

FIG.28

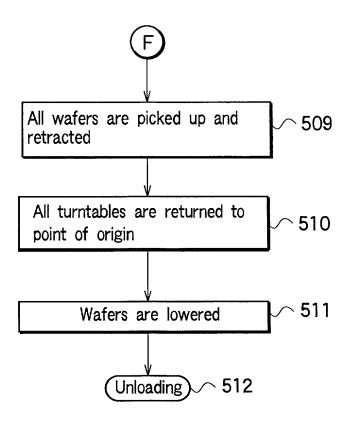


FIG.29

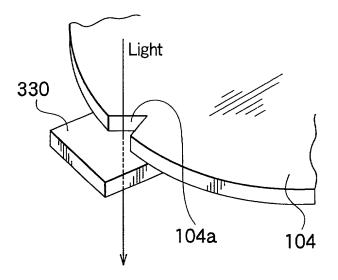


FIG.30A

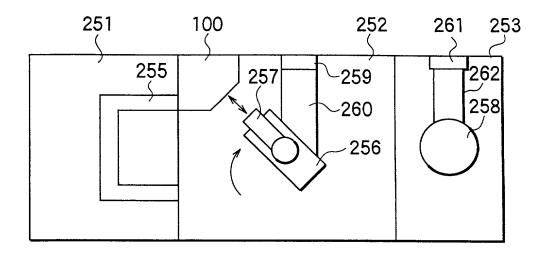


FIG.30B

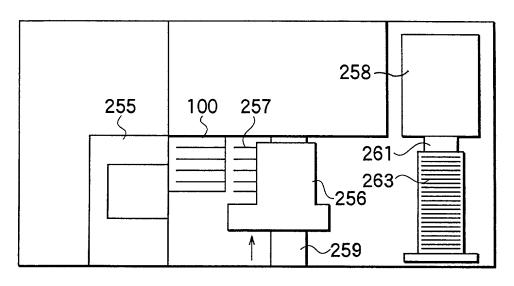
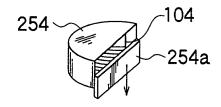


FIG.30C



30/33

FIG.31

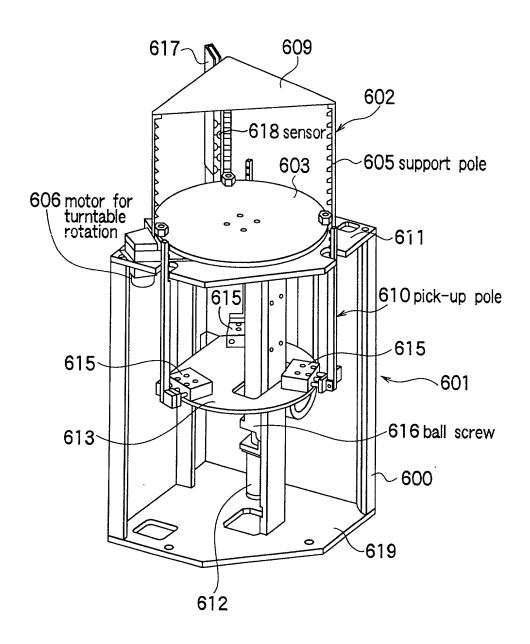


FIG.32

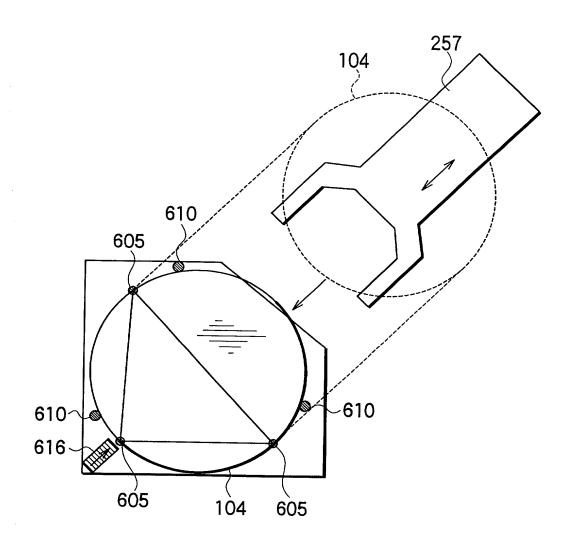


FIG.33

